



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EV077384559US

Application Serial No. 09/905,286
Filing Date July 13, 2001
Inventor Cem Basceri, et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner E. Fuller
Attorney's Docket No. MI22-1724
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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601 W. First Avenue, Suite 1300
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RECEIVED
MAR 29 2002
TC 1700

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated:

3/21/02

By:

Mark S. Matkin
Reg. No. 32,268

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